



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 15, 2024	
IGI Report Number	LG659467057
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	8.97 X 8.77 X 5.67 MM

GRADING RESULTS

Carat Weight	4.10 CARATS
Color Grade	E
Clarity Grade	VS 1

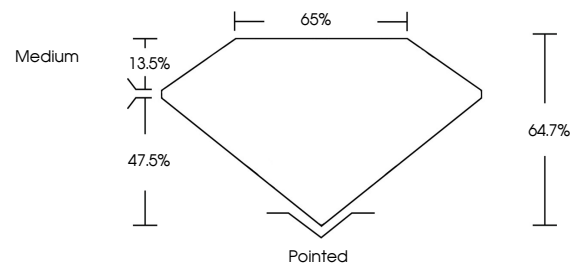
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG659467057

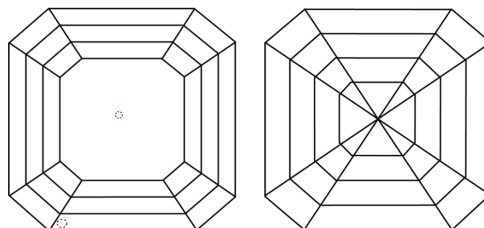
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG659467057
Report verification at igi.org

PROPORTIONS

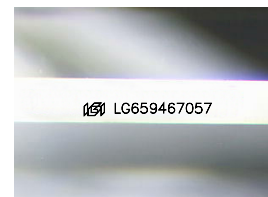


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG 659467057

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



October 15, 2024	Q1 Report No LG599467057	410 CARATS	E
SQUARE EMERALD CUT	Carat Weight	VS 1	
9.97 X 8.77 X 5.67 MM	Color Grade	64.7%	
	Clarity Grade	65%	
	Depth	Medium	
	Table		
	Girdle		
	Culet	Pointed	
	Polish	EXCELLENT	
	Symmetry	EXCELLENT	
	Fluorescence	NONE	
	Inscriptions(s)	lg51 LG599467057	

Comments:

This Laboratory Grown Diamond was
 created using a Vapor Deposition
 (CVD) growth process.

Type IIa

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.